



REPLY UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER 2800

Attorney Docket No. 002013.P135

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Seong Hyun Kim, et al.

Filed: November 25, 2003

Serial No: 10/722,818

For: VERTICAL STRUCTURE THIN
FILM TRANSISTOR

Examiner: Tuan N. Quach

Art Unit: 2814

*Enter
w/ACE
dated
8-28-05*

*C. Stanley
10-6-05*

Mail Stop AF
Commissioner for Patents
Post Office Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Dear Commissioner:

In connection with the Final Office Action mailed May 25, 2005, regarding the above-referenced application, Applicant respectfully requests consideration of the following amendments and remarks below.

*OK
to
enter
TA
10/26/05*